



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of: **HIROYAMA, Ryouji et al.**

Serial No.: **09/669,448**

Filed: **September 25, 2000**

Group Art Unit: **2815**

Examiner: **LANDAU, MATTHEW C.**

P.T.O. Confirmation No.: **2968**

FOR: **SEMICONDUCTOR LASER DEVICE AND METHOD OF MANUFACTURING
THE SAME**

RESPONSE TO THE RESTRICTION REQUIREMENT
DATED JULY 15, 2002

Commissioner for Patents
Washington, D.C. 20231

Date: August 12, 2002

Sir:

This paper is submitted in response to the Official Action dated **July 15, 2002**.

In the Action, restriction is required between Group (I), Claims 1-8, drawn to a semiconductor laser device; and Group (II), Claims 9-16, drawn to a method of manufacturing a semiconductor laser device.

Applicants hereby elect the subject matter of Group (I), Claims 1-8 for prosecution in this application. This election is made without traverse, it being understood that the applicants' rights to the filing of a divisional application directed to the non-elected subject matter under 35 USC 120 and 35 USC 121 are retained.

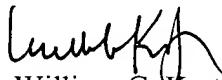
In the event that this paper is not timely filed, applicants hereby petition for an appropriate extension of time. The fee for any such extension may be charged to our Deposit Account No. 01-2340.

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Election
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In the event any additional fees are required in connection with this response, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP



William G. Kratz, Jr.
Attorney for Applicant
Reg. No. 22,631

WGK/nrp

Atty. Docket No. **001241**
Suite 1000, 1725 K Street, N.W.
Washington, D.C. 20006
(202) 659-2930



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